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To: Commissioner for Patents	Total Pages Sent: 8
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Facsimile Number: (571) 273-8300	Transmission Date: January 29, 2007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Wunnicke, <i>et al.</i>	Docket No.:	INF-138
Serial No:	10/781,920	Art Unit:	1756
Date Filed:	February 20, 2004	Examiner:	Brittany L. Raymond
Title:	Method for Fabricating a Resist Mask for Patterning Semiconductor Substrates		

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- Certification of Facsimile Transmission (1 page)
- Amendment (7 pages)

Respectfully submitted,

Nancy Milinkovich  
Legal Assistant

Confirmation Respectfully Requested

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For: Method for Fabricating a Resist Mask for Patterning Semiconductor Substrates

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed November 3, 2006. Please amend the above-referenced application as follows.